Lab4MEMS II will feature the Pilot Line for innovative technologies on advanced Micro-Opto-Electro-Mechanical Systems (MOEMS). This is not just a special class of MEMS systems in fact, but it deals with MEMS merged with Micro-optics, which involves sensing or manipulating optical signals on a very small size scale, using integrated mechanical, optical, and electrical systems. MOEMS includes a variety of devices including optical switch, array of micro-mirrors, optical cross-connect, lasers and micro lens amongst others. These devices are usually fabricated using micro-optics and standard micromachining technologies using materials like silicon, molybdenum (Mo), silicon dioxide, silicon nitride (SiOxNy), piezo coating, etc. The key findings, including MOEMS sensor’s process, design, methodology and manufacturing will be established and evaluated by means of highly impacting technology demonstrators and use-cases. The Demonstration strategy of Lab4MEMS II is two-fold:

- A suite of "proof-of-concepts" will be delivered and assessed at midterm as intermediate demonstration vehicles to prove the actual feasibility of initial device solutions, wafer substrates, process steps, tools or equipment.
- The work-flow will then converge and optimize the set of four Final Technology Demonstrators intended to become the flagship test vehicles to demonstrate the Lab4MEMS II KET Pilot Line.

Final Technology Demonstrators:
1. Pico-Projector (Leader: ST)
2. 3D Laser micro-scanner (Leader: ST)
3. NIR Micro-spectrometer (Leader: MURA)
4. SOI wafers for pico-projector & laser scanner (large cavity) (Leader: OKM)

ITE role:
ITE will be responsible for one of “proof-of-concepts” in the project - innovative applications of movable (actuated) mirror for MOEMS devices. It will be miniaturized, lightweight integrated sensor arrays system with optical readout systems. ITE works will cover design, characterization and validation activity.

ITE is also leader of dissemination and exploitation work-package in Lab4MEMS II project.

www.Lab4MEMS2.ite.waw.pl

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Lead
1 STMicroelectronics srl (Coordinator) ST-I Italy
2 Politecnico di Torino PolITO Italy
3 Politecnico di Milano PolIMI Italy
4 Consorzio Nazionale Interuniversitario per la Nanolettronica IUNET Italy
5 CNR-IMM MDM CNR Italy
6 Commissariat A Energie Atomique Et Aux Energies Alternatives CEA France
7 ARKEMA SA ARK France
8 University of Malta UoM Malta
9 Okmetic OY OKM Finland
10 MURATA Electronics MURA Finland
11 VTT Memsol Ltd. MTAB Finland
12 Teknologian tutkimuskeskus VTT VTT Finland
13 Aalto University AaU Finland
14 KLA-Tencor ICOS KLA Belgium
15 University POLITEHNICA of Bucharest - CSSNT UPB Romania
16 Instytut Technologii Elektronowej ITE Poland
17 Stiftelsen SINTEF SINTEF Norway
18 Polewall AS POL Norway
19 Besi Austria GmbH BESI Austria

ITE contact person:
Tomasz Bieniek;
phone: +48 22 2793214, tbieniek@ite.waw.pl

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